

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toru TATSUMI et al.

Title: SEMICONDUCTOR DEVICE
HAVING A MIS-TYPE FET,
AND METHODS FOR
MANUFACTURING THE
SAME AND FORMING A
METAL OXIDE FILM

Appl. No.: 10/558,271

International Filing Date: 5/31/2004
371(c) Date: 10/16/06

Examiner: Jami M. Valentine

Art Unit: 2815

Confirmation Number: 1477

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated March 7, 2008, concerning the above-referenced patent application.

Amendments to the Specification begin on page 3 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this document.

Amendments to the Drawings begin on page 6 of this document, and include attached replacement drawing sheets.

Remarks/Arguments begin on page 7 of this document.

Please amend the application as follows: